

LIST OF ART CITED BY APPLICANT

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U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE

U.S. PATENT APPLICATION PUBLICATIONS

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	

U.S. PATENT APPLICATIONS

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
NYC	JP 2002-344598	11/29/2002	Japan (English Abstract and Japanese Full Text)			X	
NYC	JP 2001-223792	08/17/2001	Japan (English Abstract and Japanese Full Text)			X	
NYC	JP 2000-182045	06/30/2000	Japan (English Abstract and Japanese Full Text)			X	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)

Copy of Japanese Office Action dated March 7, 2007.

EXAMINER /Yuk Chow/

DATE CONSIDERED 04/27/2007

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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